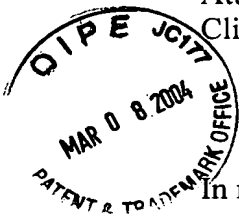


Attorney Docket: 071469-03023535
Client Reference: RAJ-001



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Confirmation Number: 1846

O'MEARA et al.

Application No.: 10/630,969

Group Art Unit: 2818

Filed: July 31, 2003

Examiner: Renee Berry

Title: FORMATION OF ULTRA-THIN OXIDE LAYERS BY SELF-LIMITING
INTERFACIAL OXIDATION

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Non-Fee Amendments
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 12, 2004, Applicants elects claims 1-31, drawn to a method of forming a semiconductor microstructure, with traverse for examination in this application.

Respectfully submitted,
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